Express Mail No. EL 640 011 113 US

Docket No.: OPS Case 529

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April 3, 2001

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[0029] Fig. 1 is a viewFigs. 1(a), 1(b), 1(c) and 1(d) are views for showing the principle of halftone phase shifting lithography.

[0030] Fig. 2 is a viewFigs. 2(a), 2(b), 2(c) and 2(d) are views for showing conventional lithography against Fig. 1.

[0033] Fig. 5 is a viewFigs. 5(a) and 5(b) are views for showing a state in which phase difference and transmittance are changed by applying excimer laser to a halftone phase shifting photomask having the halftone phase shifting film containing chromium and fluorine.

[0035] Fig. 7 is a viewFigs. 7(a) and 7(b) are views for showing that the spectrum analyzed from reflectance of X-rays (of after Fourier transform) is changed by applying excimer laser to a halftone phase shifting photomask having the halftone phase shifting film containing chromium and fluorine, in which Fig. 7(a) shows the spectrum analyzed from reflectance of X-rays of before the applying of excimer laser to the halftone phase shifting photomask, and Fig. 7(b) shows the spectrum analyzed from reflectance of X-rays of after the applying of excimer laser to the halftone phase shifting photomask.

[0036] Fig. 8 is a viewFigs. 8(a), 8(b), 8(c) 8(d) and 8(e) are views for illustrating the processes in which blanks for halftone phase shifting photomask are produced and then a halftone phase shifting photomask of example 1 is obtained by processing the blanks for halftone phase shifting photomask.

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[0038] Fig. 10 is a viewFigs. 10(a), 10(b), 10(c) and 10(d) are views for illustrating the process for producing a halftone phase shifting photomask of Example 2.

[0039] Fig. 11 is a viewFigs. 11(a) and 11(b) are views for showing the phase difference change and the transmittance change due to applying excimer laser to a halftone phase shifting photomask having halftone phase shifting film of Example 1.

[0040] Fig.12 is a viewFigs. 12(a) and 12(b) are views for showing the phase difference change and the transmittance change due to applying excimer laser to a halftone phase shifting photomask having halftone phase shifting film of Example 4.

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[0030] Figs. 2(a), 2(b), 2(c) and 2(d) are views for showing conventional lithography against Fig. 1.

[0033] Figs. 5(a) and 5(b) are views for showing a state in which phase difference and transmittance are changed by applying excimer laser to a halftone phase shifting photomask having the halftone phase shifting film containing chromium and fluorine.

[0035] Figs. 7(a) and 7(b) are views for showing that the spectrum analyzed from reflectance of X-rays (of after Fourier transform) is changed by applying excimer laser to a halftone phase shifting photomask having the halftone phase shifting film containing chromium and fluorine, in which Fig. 7(a) shows the spectrum analyzed from reflectance of X-rays of before the applying of excimer laser to the halftone phase shifting photomask, and Fig. 7(b) shows the spectrum analyzed from reflectance of X-rays of after the applying of excimer laser to the halftone phase shifting photomask.

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[0036] Figs. 8(a), 8(b), 8(c) 8(d) and 8(e) are views for illustrating the processes in which blanks for halftone phase shifting photomask are produced and then a halftone phase shifting photomask of example 1 is obtained by processing the blanks for halftone phase shifting photomask.

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[0038] Figs. 10(a), 10(b), 10(c) and 10(d) are views for illustrating the process for producing a halftone phase shifting photomask of Example 2.

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[0039] Figs. 11(a) and 11(b) are views for showing the phase difference change and the transmittance change due to applying excimer laser to a halftone phase shifting photomask having halftone phase shifting film of Example 1.

[0040] Figs. 12(a) and 12(b) are views for showing the phase difference change and the transmittance change due to applying excimer laser to a halftone phase shifting photomask having halftone phase shifting film of Example 4.